

PLEASE ST/AMP TO ACKNOWLEDGE RECEIPT OF THE FOLLOWING:
In Re Application of:

Serial No.: 09/784,200

Filed: February 26, 2001

For: CHEMICAL LIQUID PROCESSING APPARATUS FOR PROCESSING A
SUBSTRATE AND THE METHOD THEREOF

BOX MISSING PART

1. Check for \$ 130.00
2. Response To Notice To File Missing Parts
3. Copy of Notice To File Missing Parts
4. Declaration and Power of Attorney
5. Claim For Priority
6. Certified copies of Japanese Application Nos. 2000-039683 and 2000-297441, filed February 17, 2000 and September 28, 2000, respectively.

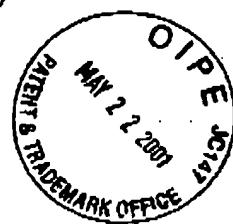
Dated: May 22, 2001

CASE REF: 03180.0273

(Due Date: May 22, 2001)

RVB/FPD/bi

MAY 22 2001



2001

Attorney Docket No.:03180.0273
Customer Number: 22,852

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shinichi ITO et al.

Serial No.: 09/784,200

Group Art Unit: 1762

Filed: February 16, 2001

Examiner:

For: CHEMICAL LIQUID PROCESSING APPARATUS FOR PROCESSING A
SUBSTRATE AND THE METHOD THEREOF

CLAIM FOR PRIORITY

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

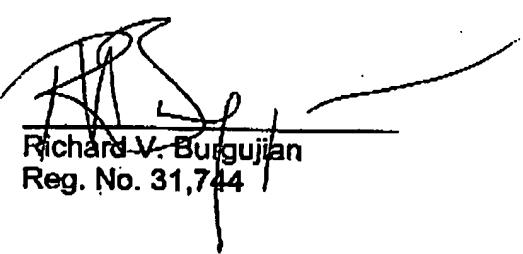
Under the provisions of 35 U.S.C. § 119, Applicants hereby claim the
benefit of the filing date of Japanese Patent Application Nos. 2000-039683 and
2000-297441, filed February 17, 2000 and September 28, 2000, respectively, for
the above-identified U.S. patent application.

In support of this claim for priority, enclosed are two certified copies of the
priority applications.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


Richard V. Burgujian
Reg. No. 31,744

Date: May 22, 2001
RVB/FPD/bl
Enclosures

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日本国特許庁
PATENT OFFICE
JAPANESE GOVERNMENT

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

Best Available Copy

出願年月日
Date of Application:

2000年 2月 17日

出願番号
Application Number:

特願2000-039683

出願人
Applicant (s):

株式会社東芝

2000年11月10日

特許庁長官
Commissioner,
Patent Office

及川耕造



出証番号 出証特2000-3094618

日本国特許庁
PATENT OFFICE
JAPANESE GOVERNMENT

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る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

Best Available Copy

出願年月日
Date of Application:

2000年 9月28日

出願番号
Application Number:

特願2000-297441

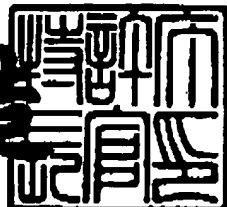
出願人
Applicant(s):

株式会社東芝

2001年 3月 2日

特許庁長官
Commissioner,
Patent Office

及川耕造



出証番号 出証特2001-3012425